DEC 2 6 2007 WE THAT EVILLED STATES PATENT AND TRADEMARK OFFICE

In re application of

Confirmation No. 9850

Shinji KAJITA et al.

Attorney Docket No. 2004 0120A

Serial No. 10/765,182

Group Art Unit 1746

Filed January 28, 2004

Examiner Mark J. Heckert

APPARATUS FOR AND METHOD OF PROCESSING SUBSTRATE

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**AMENDMENT** 

THE COMMISIONER IS AUTHORIZETHE THE COMMISIONER IS AUTHORIZETHE TO DEPOSIT TO CHARGE ANY DEFICIENCY IN THE TO DEPOSIT FEES FOR THIS PAPER TO DEPOSIT FEES FOR THIS PAPER TO DEPOSIT ACCOUNT NO. 23-0975

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Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action of September 26, 2007, please amend the above-referenced U.S. patent application as follows:

RESPONSE UNDER 37.CFR 1.116 EXPEDITED PROCEDURE EXAMINING GROUP 1746

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